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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Iwao Hatanaka

Art Unit: 2141

Serial Number: 09/781,616

Examiner: Lien, Tan

Filing Date: 02/12/2001

Docket No.: CHA9-99-015

Title: METHOD AND SYSTEM FOR AUTOMATED SESSION RESOURCE
CLEAN-UP IN A DISTRIBUTED CLIENT-SERVER ENVIRONMENT

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Dear Sir:

I. Introductory Comments

This paper is being filed with a Request for Continued Examination (RCE), in response to the Final Office Action dated November 23, 2004. Consideration and allowance are respectfully requested.

09/781,616

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